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5-6-02

J1046 U.S. PTO
10/098501

03/18/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kensaku Motoki, et al.
Serial No. : To Be Assigned Art Unit : To Be Assigned
Filed : March 18, 2002 Examiner : To Be Assigned
For : OXYGEN DOPING METHOD TO GALLIUM NITRIDE SINGLE CRYSTAL
SUBSTRATE AND OXYGEN-DOPED N-TYPE GALLIUM
NITRIDE FREESTANDING SINGLE CRYSTAL SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of the documents cited therein.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed with the present application, and therefore it is believed that no fees are due under 37 C.F.R. Section 1.97(i).

Respectfully submitted,
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March 18, 2002